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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 09/298,160  
Filing Date .... April 22, 1999  
Inventor .... Dan G. Custer et al.  
Assignee .... Micron Technology, Inc.  
Group Art Unit .... 1763  
Examiner .... A.W. Olsen  
Attorney's Docket No. .... MI22-1172  
Title: Polishing Systems, Method of Polishing Substrates, and Methods of Preparing  
Liquids for Semiconductor Fabrication Processes

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References - - See attached Form PTO-1449


In compliance with 37 C.F.R. §§ 1.56, 1.97 and 1.98, your attention is directed to  
the United States patents and other references listed on the attached Form PTO-1449.

No admission is made regarding whether all the submitted references are prior art.

Citation of these references is respectfully requested.

Respectfully submitted,

Date: 9-26-03

  
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Form PTO 1449 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1172		SERIAL NO. 09/298,160	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Dan G. Custer et al.	
FILING DATE April 22, 1999				GROUP	

U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	6,416,676 B1	07/09/02	Hill			
	AB	5,766,321	06/16/98	Ishihara et al.			
	AC	5,110,741	05/05/92	Ohi et al.			
	AD	4,894,342	01/16/90	Guinn et al.			
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
	AL	WO 94/23816	PCT			Yes	No
	AM						
	AN						
	AO						
	AP						

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
	AR	Hodgman, M.S., Charles D., "Handbook of Chemistry and Physics	A Ready-Reference Book of Chemical and
		Physical Data," 27 Ed., ©1910, 3 pages.	
	AS		
	AT		

EXAMINER	DATE CONSIDERED
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.